



1F123
Docket No.: 9323.051.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
In-Kwon Jeong

Confirmation No.: 3412

Application No.: 09/931,695

Art Unit: 1753

Filed: August 16, 2001

Examiner: B. L. Mutschler

For: SYSTEM AND METHOD FOR PROCESSING
SEMICONDUCTOR WAFERS USING
DIFFERENT WAFER PROCESSES

Customer No.: 30827

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Official Action dated March 22, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 7 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 8 of this paper.

An **Appendix** including amended drawing figures is attached following page 8 of this paper.